

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/770,125	NAKAYAMA ET AL.	
Examiner	Art Unit	
David J. Walczak	3751	

CEAROUER					
SEARCHED					
Class	Subclass	Date	Examiner		
	-				

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
updated prior search	5/16/2005	DW	